9 All 2824

O 1 P LL 3 C 115 JOHN STEWN

PATENT DOCKET NO. AMAT/2253.P1/AKT/SB

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: J. White, et al.

Serial No.:

09/082,483

Filed:

May 20, 1998

For:

Modular Substrate

Processing System

Assistant Commissioner for Patents Washington, D.C. 20231

Dear Sir:

Group Art Unit:

2824

Examiner:

P. Luu

CERTIFICATE OF MAILING

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RESPONSE TO RESTRICTION REQUIREMENT AND AMENDMENT

In response to the Office Action dated January 20, 2000, having a one-month response period set to expire on February 20, 2000, the Applicants elect claims 1-45, 47-58.

In the claims:

Please cancel claim 46 without prejudice.

REMARKS

This response is intended as a full and complete response to the Office Action dated January 20, 2000. Restriction to one of the following inventions is required under 35 U.S.C. § 121:

I. Claims 1-45, 47-58, drawn to an apparatus for performing a process, classified in class 257, subclass 437.

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